

First results on the final readout chip for the High-Luminosity LHC upgrade of the CMS Inner Tracker

Michael Grippo^{1,2} Nazar Bartosik²

Nazar Bartosik² Natale Demaria² Fabio Luongo^{1,2}

Istituto Nazionale di Fisica Nucleare

¹University of Turin ²INFN Turin

The CMS Readout Chip (CROC)

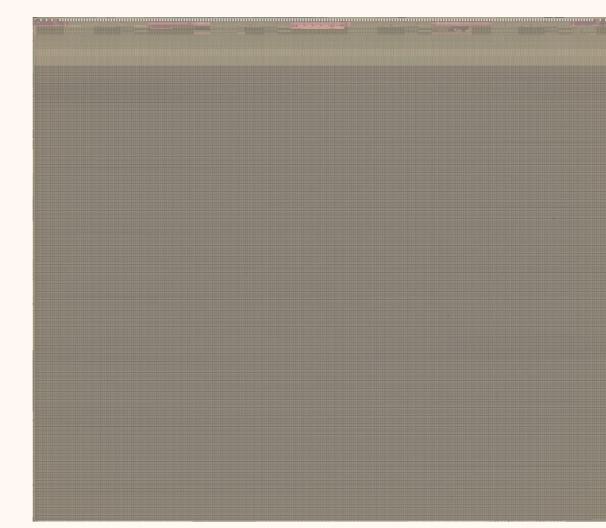
 CMS Inner Tracker for High-Luminosity LHC (HL-LHC): pixel detector instrumented with 10⁴ CMS Readout Chips (CROCs)

• CROC characteristics:

- 65 nm technology readout chip
- Developed by the joint ATLAS-CMS RD53 collaboration
- 432×336 pixel cells in approximately 4 cm^2
- Very complex digital architecture for high energy physics
- Serial powering for detector modules
- Prototype chip (CROCv1) produced in 2021
- Production chip (CROCv2) received in 01/2024
 - Engineering run with 20 wafers (4 on hold at foundry)
 - First tests performed at wafer level



Results from the CROCv2 engineering run



Composite picture of CROCv2 ASIC

• CROCv2 ASIC verified at wafer level

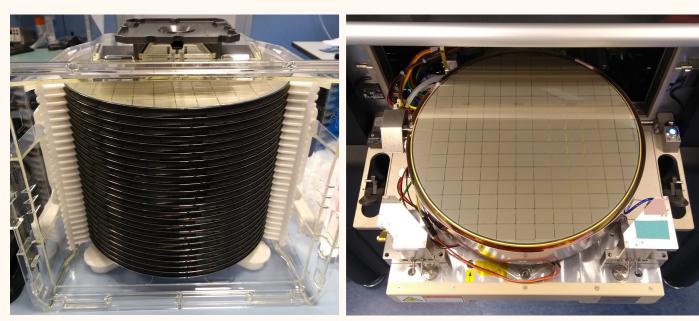
- Most functionalities tested
- Quickly verified several design improvements (CROCv1 → CROCv2)
- Confirmed few known limitations not expected to affect detector operation
- → CROCv2 chip functioning as expected
- Collected characterisation data for approximately 1900 chips
 - Startup current: 0.69 A (ana) + 0.40 A (dig)
- Pixel current: 5.1 μA (ana) + 2.9 μA (dig)
- Threshold σ after tuning (2700 e): ~ 40 e
- Mean noise: \sim 70 e



Logos on a CROCv2 chip

CROC waferprobing setup

- Waferprobing facility: clean room of the INFN-TO Technological Laboratory
- 14 CROCv2 engineering run wafers tested
 - $\emptyset = 300 \text{ mm}$; 136 chips / wafer

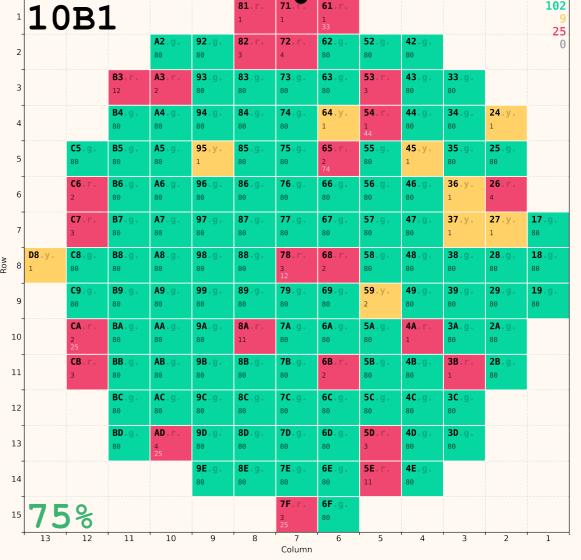


CROCv2 wafers in foundry box and on probe station

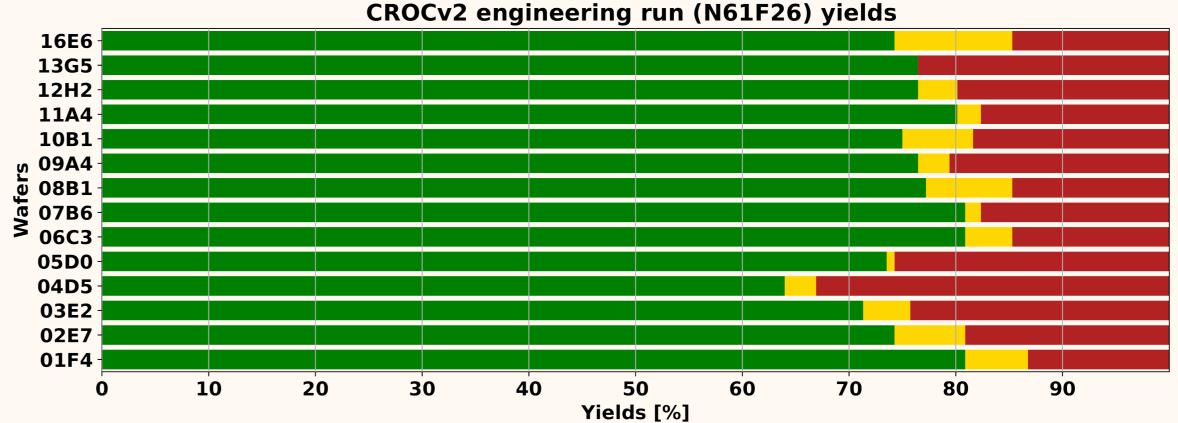
- Automated wafer testing: 21.5 h for each wafer
- Wafer-level testing hardware
 - Probe station: Cascade Microtech CM300xi (semi-automated)
 - Probe card: 194 tungsten needles to contact aluminium pads
 - Waferprobing auxiliary card: probe card control from PC
 - DAQ: FC7 board (Kintex 7 FPGA)
 - Remotely controllable instruments

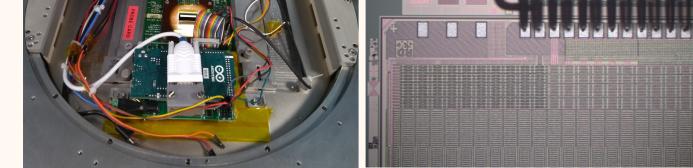


- Average yield for CROCv2 wafers: 77 %
 - 104 green chips per wafer on average
 - Higher yield than CROCv1 (75%)
 - Green chips: on detector ✓
 - Yellow chips: marginal !
 - Red chips: defective X
- Failure rates of waferprobing tests
 - Results match CROCv1 data overall
 - Defects mostly in **pixel array**
 - Digital signal injections: 11 % failure rate
- Pixel registers: 5 % failure rate
- Higher die failure rate near wafer edge
 - $\bullet\,$ Can be up to $\sim 80\,\%$



Example of CROCv2 wafermap





Waferprobing hardware and chip under test

• Wafer-level testing software

- WLT software (Python): **croc_wlt**
- DAQ software (C++): Ph2_ACF

• Chip testing procedures

- Power consumption and chip signals
- Chip trimming (main reference current and core voltages)
- Communication testing
- Global and pixel registers
- Chip calibrations (ADC, DACs, ring oscillators and T sensors)
- Scan chain
- Shunt-LDO IV
- Pixel array testing (occupancy and S-curves)

Discussion

- Verified and characterised first CROCv2 wafers from engineering run
- CROCv2 chip functioning as expected
- Higher chip yields from waferprobing with respect to CROCv1, even with more tests
- Produced first single-chip testing boards and digital detector modules (i.e. without sensors)
- First CROCv2 production batch received in May 2024: currently under test!

Acknowledgements

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References

- The Phase-2 Upgrade of the CMS Tracker CMS Collaboration (2017). Link: cds.cern.ch/record/2272264
- Chip reference manuals. Link: cds.cern.ch/record/2890222
- Wafer-level testing software repository. Link: gitlab.cern.ch/croc_testing/croc_wlt

Contact: michael.grippo@cern.ch

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Chip yields for CROCv2 engineering run